PATENT APPLICATION

## 00862.022453

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
KENICHI KOTOKU	: Examiner: P. Hassar	ızadeh
	: Group Art Unit: 176	3
Application No.: 09/960,694	) : Confirmation No.: 5	254
Filed: September 24, 2001	)	1
For: EXPOSURE APPARATUS AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD	: November 21, 2003 :	3 - - - - -
MANOTACTORING METHOD	,	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Preliminary Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	17	MINUS	20	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	5	MINUS	5	= 0	x \$43 \$86	\$0.00
Fee for Multip	ole Dependent claims	\$145/\$290				
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.
	Respectfully submitted,

Λ .

Attorney for Applicant Daniel S. Glueck

Registration No. 37,838

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800

Facsimile: (212) 218-2200

DSG/dc

DC\_MAIN 150458v1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:	)	Examiner: P. Hassanzadel	h		
KEN	СНІ КОТОКИ	· )	Group Art Unit: 1763			
Appli	cation No.: 09/960,694	)	Confirmation No.: 5254			
Filed	September 24, 2001	)	Communation 1vo 3234	:		· ·
For:	EXPOSURE APPARATUS AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD	; ;	November 21, 2003			

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows: